

Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
BRS	L1	25	indium adj doped adj2 (silicon or poly or polysilicon)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:39			0
BRS	L2	0	(in-situ or insitu or (in adj situ)) with (CVD or (chemical adj vapor adj deposit\$5)) with (silicon or polysilicon or poly\$1) with indium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 13:31			0
BRS	L3	10	(in-situ or insitu or (in adj situ)) with (silicon or polysilicon or poly\$1) with indium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 11:54			0
BRS	L4	272	(in-situ or insitu or (in adj situ)) with (CVD or (chemical adj vapor adj deposit\$5)) with (silicon or polysilicon or poly\$1) with (indium or In or "In")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:03			0
BRS	L5	9328 0	indium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 11:59			0

Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Error Rows
BRS	L6	17	4 and 5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 11:59			0
BRS	L7	481	(in-situ or insitu or (in adj situ)) with (CVD or (chemical adj vapor adj deposits\$5)) with (indium or In or "In")	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:03			0
BRS	L8	24	7 and 5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:04			0
BRS	L9	7	8 not 6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:04			0
BRS	L10	969	indium adj (chloride\$1 or trichloride\$1 or tri-chloride\$1 or (tri adj chloride\$1))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:41			0
BRS	L11	968	InCl3 or "InCl3" or "InCl.sub.3" or "In Cl.sub.3"	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:42			0

Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
BRS	L12	1776	10 or 11	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:42			0
BRS	L13	2	(in-situ or insitu or (in adj situ)) with 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:44			0
BRS	L14	2913	(implant\$8 or dop\$4 or inject\$4 or introduc\$4) with (indium or In or "In") with (silicon or poly\$1 or polysilicon\$1 or poly-silicon\$1)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:46			0
BRS	L15	4670	14 and 5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:46			0
BRS	L16	149	15 and 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:47			0

Type	L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Error
BRS	L17	8	14 same 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 12:48			0
BRS	L18	0	(in-situ or insitu or (in adj situ)) same (silicon or polysilicon or poly\$1 or poly-silicon) same 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 13:56			0
BRS	L19	64	(in-situ or insitu or (in adj situ)) and (silicon or polysilicon or poly\$1 or poly-silicon) and 12	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 13:42			0
IS&RI	L20	1	("20040000695").PN.	USPAT; US-PGPUB	2004/10/07 13:42			0
BRS	L21	3	16 and (in-situ or insitu or (in adj situ))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2004/10/07 13:56			0